

23 April 2003

09/825,648

L Number	Hits	Search Text	DB	Time stamp
1	6	((("6017437") or ("6183611") or ("6241825"))).PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/23 12:26
2	17	("3826558" "4086870" "5000827" "5024746" "5095848" "5256274" "5368711" "5429733" "5437777" "5441629" "5447615" "5516414" "5830805" "5853559" "5885353" "5891251" "6019164").PN.	USPAT	2003/04/23 11:56
3	2473	205/118,122,123,125,295,640.ccls. or 204/297.01,297.06,297.07,297.1.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/23 12:27
4	2	(205/118,122,123,125,295,640.ccls. or 204/297.01,297.06,297.07,297.1.ccls.) and ((chuck or (wafer adj support) or platen or platform) near (adjustable or compliant or resilient or deformable or tiltable))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/23 12:31
5	7	(205/118,122,123,125,295,640.ccls. or 204/297.01,297.06,297.07,297.1.ccls.) and ((chuck or (wafer adj support) or platen or platform or support) near (adjustable or compliant or resilient or deformable or tiltable))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/23 12:36
6	686	(205/118,122,123,125,295,640.ccls. or 204/297.01,297.06,297.07,297.1.ccls.) and (wafer or microelectronic or semiconductor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/23 12:40
7	11	((205/118,122,123,125,295,640.ccls. or 204/297.01,297.06,297.07,297.1.ccls.) and (wafer or microelectronic or semiconductor)) and ((chuck or (wafer adj support) or platen or platform or support) with (adjustable or compliant or resilient or deformable or tiltable))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/23 12:33
8	8	(205/118,122,123,125,295,640.ccls. or 204/297.01,297.06,297.07,297.1.ccls.) and ((chuck or (wafer adj support) or platen or platform or support) near (adjustable or compliant or resilient or deformable or tiltable or conformable or conforming))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/23 12:39
9	58692	204/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/23 12:39
10	70	204/\$.ccls. and ((chuck or (wafer adj support) or platen or platform or support) near (adjustable or compliant or resilient or deformable or tiltable or conformable or conforming))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/23 12:40
11	10	(204/\$.ccls. and ((chuck or (wafer adj support) or platen or platform or support) near (adjustable or compliant or resilient or deformable or tiltable or conformable or conforming)))) and (wafer or microelectronic or semiconductor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/23 12:40

18	7	6019164.URPN.	USPAT	2003/04/23 12:45
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